

FAX RECEIVED

APR 16 2003

GROUP 1700

Attorney's Docket No. 051876.P232

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Won-Ick Jang, et al.

Serial No. 09/753,065

Filed: 12-23-2000

For: **STICTION-FREE
MICROSTRUCTURE RELEASING
METHOD FOR FABRICATING
MEMS DEVICE**

Examiner: Lan Vinh

Art Unit: 1765

Confirmation No. 9323

#6/a
JSL
4/17/03

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Box AF - Non-Fee
Commissioner for Patents
Washington, D.C. 20231

Dear Commissioner:

In response to the Office Action mailed January 15, 2003, Applicants respectfully requests consideration of the following amendments and remarks below.

09/753,065

51876.P232
ESH/SL